



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
United States Patent and Trademark Office  
Address: COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, Virginia 22313-1450  
www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 9488

SERIAL NUMBER 10/677,309	FILING DATE 10/03/2003 RULE ✓	CLASS 216	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. 243579US0X
-----------------------------	-------------------------------------	--------------	------------------------	-----------------------------------

## APPLICANTS

Tetsuo Suzuki, Kobe-shi, JAPAN;

Satoru Takada, Hayward, CA;

\*\* CONTINUING DATA \*\*\*\*\*

NONE *note*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

NONE *note*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 04/28/2004

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY JAPAN ✓	SHEETS DRAWING 6 ✓	TOTAL CLAIMS 13 ✓	INDEPENDENT CLAIMS 1 ✓
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature <i>Maureen H. Jones</i> Initials <i>MT</i>				

## ADDRESS

22850  
OBLON, SPIVAK, MCCLELLAND, MAIER & NEUSTADT, P.C.  
1940 DUKE STREET  
ALEXANDRIA, VA  
22314

## TITLE

Method of reclaiming silicon wafers

FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
-------------------------------	---	---